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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10016610	FILING DATE 10/30/2001	CLASS 414	SUBCLASS 77	GAU 3652	EXAMINER F. LIE
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**APPLICANTS: McGowan Richard;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO SC0251WD
TITLE : Wafer management system and methods for managing wafers		
U.S. DEPT. OF COMM./PAT. & TN-PTO-435L(Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
<input type="checkbox"/> TERMINAL		Primary Examiner		
DISCLAIMER		Application Examiner		
PREPARED FOR ISSUE				
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